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Invention Title: Technique to Optimize EUV Lithography Light Source from Laser-Produced Plasma

UCSD Docket No: SD2006-165

Inventor(s): Mark S. Tillack, Yezheng Tao

U.S. Filing/Issue Date: 4/9/2007; 10/10/2008; 04/12/2006

Patent or Application Serial No: PCT/US07/66245; 12/296,707; 60/791,243

Grant/Contract Number(s): DOE DE-FG03-99ER54547

Foreign Applications filed/intended in (countries): none at present

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PATENT REEL: 022206,FRAME, 0699 \*\*